

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Nestor BOJARCZUK JR., et al.

Serial No.:

10/059,422

Group Art Unit:

2814

Filed:

January 31, 2002

Examiner:

Theresa Doan

METHOD OF FORMING LATTICE-MATCHED STRUCTURE ON SILICON AND

STRUCTURE FORMED THEREBY

Honorable Commissioner for Patents Alexandria, VA 22313-1450 **BOX AF**

PETITION AND FEE FOR EXTENSION OF TIME UNDER 37 C.F.R. 1.136(a)

Sir:

Applicant hereby petitions for a One-month extension of time to respond to the Office Action mailed October 20, 2004. The extension fee in the amount of \$ 120.00 is included in the total for the R.C.E. in the amount of \$910. A Request for Continued Examination responsive to the outstanding Office Action is being filed simultaneously herewith. A duplicate copy of this sheet is enclosed.

Please charge Assignee's Deposit Account No. 50-0510 the amount of the \$910.00 for the One-month extension fee and R.C.E. fee.

The Commissioner is authorized charge any deficiencies in fees and credit any overpayment of fees to Assignee's Deposit Account No. 50-0510.

Respectfully submitted,

02/22/2005 RFEKADU1 00000064 500510

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120.00 DA

Phillip E. Miller

Registration No. 46,060

McGinn & Gibb, PLLC

Intellectual Property Law 8321 Old Courthouse Road, Suite 200 Vienna, VA 22182-3817

(703) 761-4100

Customer No. 21254